


<b>Search Notes</b>  	<b>Application/Control No.</b>  10711416	<b>Applicant(s)/Patent Under Reexamination</b>  DORIS ET AL.
	<b>Examiner</b>  Wai-Sing Louie	<b>Art Unit</b>  2814

SEARCHED			
Class	Subclass	Date	Examiner
438	164	9/21/06	MDH
257	335	9/21/06	MDH
257	67, 347, 351	12/18/07	WSL
438	149,154,157	12/18/07	WSL

SEARCH NOTES		
Search Notes	Date	Examiner
wafer bonding, through hole, epitaxial growth, crystal orientation, buried oxide layer, oxygen implanting, annealing	12/18/07	WSL

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
438	149,154,157	12/18/07	WSL